(FD)

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Howard Ge et al.						Docket No. 34261-8500		
Application No.	Filing Date	Examiner		Customer N	0.	Group Art Uni	t Confirmation No.	
10/680,960	October 7, 2003	Chacko Davis, Daborah		21611		1756	6075	
Invention: OPHOTORESIST COATING PROCESS FOR MICROLITHOGRAPHY MAR 0 9 2007								
COMMISSIONER FOR PATENTS:								
Transmitted herewith is an amendment in the above-identified application.								
The fee has been calculated and is transmitted as shown below.								
CLAIMS AS AMENDED								
_	CLAIMS REMAINING	HIGHEST #		ER EXTRA		RATE	ADDITIONAL	
TOTAL CLAIMS	AFTER AMENDMENT 18 -	PREV. PAID FOR	CLAIMS	PRESENT 0	<u> </u>	\$50.00	FEE \$0.00	
INDEP. CLAIMS	3 -	3 =			<u>x</u>	\$200.00	\$0.00	
Multiple Dependent Claims (check if applicable)							\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00								
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 19-2814 ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. 								
Dated: March 9, 2007								
Albin H. Gess Registration No. 2 SNELL & WILM 600 Anton Blvd., 5 Costa Mesa, Calif Tel. (714) 427-702 Fax (714) 427-779	ER LLP Suite 1400 Fornia 92626	<u>C</u>	I hereby with the "Express the Con on M"	certify that the United States is Mail No. Eynmissioner for	Post Post Pat	lowing correspor al Service with s 22.32.89.51 ents, P.O. Box 1	450, Alexandria, VA	
CC:				Printed Name				



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Patent Examiner: Chacko Davis, Daborah

Howard Ge, et al.

Group Art Unit: 1756

Serial No.: 10/680,960

Confirmation No.: 6075

Filed: October 7, 2003

Title: PHOTORESIST COATING PROCESS

FOR MICROLITHOGRAPHY

March 9, 2007

Costa Mesa, California 92626

RESPONSE TO OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of December 11, 2006, kindly amend the above-identified application as follows: